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PATENT  
Attorney Docket No. 1110/97825

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application )  
)  
Applicant: KOZO NAKAMURA ET AL. )  
)  
Serial No.: Not Available )  
)  
Filed: July 17, 2006 )  
)  
For: METHOD FOR PREDICTING PRECIPITATION )  
BEHAVIOR OF OXYGEN IN SILICON SINGLE )  
CRYSTAL, METHOD FOR DETERMINING )  
PRODUCTION PARAMETER OF SILICON )  
SINGLE CRYSTAL, AND STORAGE MEDIUM )  
FOR STORING PROGRAM FOR PREDICTING )  
PRECIPITATION BEHAVIOR OF OXYGEN IN )  
SILICON SINGLE CRYSTAL )  
)  
Examiner: Not Available )  
)  
Art Unit: Not Available )

PRELIMINARY AMENDMENT

Mail Stop  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please make the following amendments, preliminary to examination of the subject application.